I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail, in an envelope addressed to: MS Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.

Nated: December 26, 2006

gnature: (Reta Mollalaghababa)

Docket No.: 101430-131RCE2

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re

Application of:

Ward Dean Halverson

Confirmation No.: 8164

Application No.:09/849,065

Art Unit: 1762

Filed: May 4, 2001

Examiner: Padgett, Marianne L.

For: METHOD AND APPARATUS FOR

TREATING SURFACES WITH A PLASMA GENERATED BY ELECTRON CYCLOTRON

RESONANCE

RESPONSE

MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

In response to the Office Action issued on June 23, 2006 in the above-referenced patent application, Applicants provide the following amendments and remarks. Reconsideration and allowance of the application are respectfully requested.

A Listing of Claims begins on Page 2.

Remarks begin on Page 10.